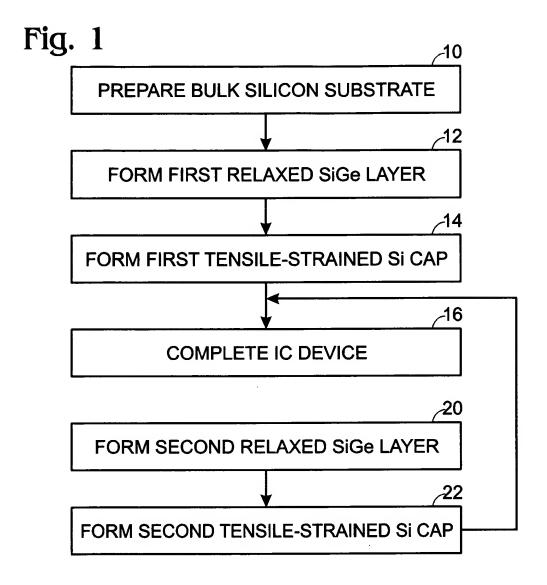
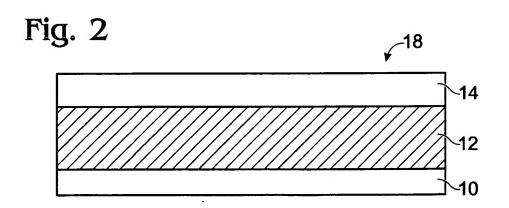
Method of Forming Local "Silicon-on-Nothing" or "Silicon-on-Insulator" wafers with Tensile-strained Silicon
SLA Docket No.: SLA.0586
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